Se	earch Notes						

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/020,854	SCOTT ET AL.	
Examiner	Art Unit	
 Venkatesh Halivur	2619	

	SEARCHED			
Class	Subclass	Date	Examiner	
370	389,400, 401,475, 395.3, 395.54	11/9/2007	VH	
711	202	11/9/2007	VH	
	205	11/9/2007	VH	
	207	11/9/2007	VH	
Above	Updated	11/9/2007	VH	
		-		

INTERFERENCE SEARCHED			
Class	Subclass	Date	Examiner
370	389,395.3	11/9/2007	VH
711	207	11/9/2007	VH
Interference Search History Printout		11/9/2007	VH

SEARCH NOTES (INCLUDING SEARCH STRATEGY)			
	DATE	EXMR	
EAST(class/subclass updated)	11/9/2007	VH	
EAST(Text search updated)	11/9/2007	VH	
NPL IEEE Xplore	11/9/2007	VH	
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